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## Progress on the "Slim Edges" Project

Tuesday 22 November 2011 11:30 (20 minutes)

The UCSC-NRL "Slim Edges" Project made good progress.

The laser scribing+cleaving was replaced by XeF2 etching+cleaving leading to a much improved i-V curve. The edge psssivation has also been finalized with Alumina for p-type sensors and Nitrogen PECVD for n-type. Charge collection will be discussed in a second talk

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